

PRODUCT BROCHURE

Double Image Microscope

Our range of digital microscopes, with single or twin cameras, meets the different needs for substrate visualisation and fine alignment.



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Idonus proposes a range of modular digital microscopes suitable for the observation of micromechanical parts and micrometre-scale features. The basic system is a Single Image Microscope (*SIM*) with reflected light illumination. When used in pairs and mounted on an adjustable stand, it provides a Dual Image Microscope (*DIM*) designed for on-screen visualisation during in-plane alignment operations (*e.g.*, when combined with our shadow mask aligner, *SMA*).

Applications

The primary use of our cost-effective digital microscopes is for UV photolithography in cleanrooms. Before UV exposure, the substrate needs to be precisely aligned with a mask and this procedure can be completed using one of our digital microscope. Our products are thus designed to allow bulky auxiliary equipment to be placed under the units. For example, many of our clients use the Dual Image Microscope (*DIM*) as a laboratory equipment for on-screen visualisation during fine inplane alignment operations. A typical application is illustrated in Figure 1 where a *DIM* is combined with our Shadow Mask Aligner (*SMA*).

Working principle

Our series of digital microscopes integrate reflected light optics, also referred to as episcopic illumination (or epi-illumination). This illumination means is applicable

for the observation of a wide range of materials and meets most needs in terms of inspection of microsystems.

Köhler illumination – Quality of the illumination is an essential criterion in optical microscopy. This is especially true for quantitative digital imaging. We integrate a light emitting diode (LED) system that provides homogenous illumination thanks to the Köhler illumination technique.¹ With this lighting optics, the light source is completely defocused and not visible in the resulting image (see Figure 2). This ensures high-quality imaging and usability of the recorded images for postprocessing (e.g., for machine vision).

Green LED – Green light illumination comes as

standard, as it is a wavelength (around 550 nm) suitable for UV applications. Any other wavelength is of course possible. In particular, IR illumination and IR sensitive cameras are available upon request. Note that Idonus also proposes an IR microscope dedicated to the inspection of buried silicon oxide (SiO₂) in silicon-based wafers.²

Range of products

Our Single and Dual Image Microscopes (*SIM / DIM*) are all built from a tubular optical module whose principle is depicted in Figure 1. The constitutive elements of our *SIM* series of digital microscopes are:

- SIM optics
 - ×1 Tubular optics with integrated homogeneous green light LED illumination
 - ×1 Fixed-magnification objective (focusing is ensured with a knob for the "infinity corrected"



Figure 1: A Double Image Microscope (DIM) combined with an $XY\theta$ shadow mask alignment stage. The stage shown in this 3D model is designed for 4" wafers. The DIM consists of two tubular microscopes that can be screw-adjusted to fit with any wafer size.

² For further details on our IR-microscope, check our website: idonus.com/products/mems-products/infrared-microscope.html

¹ A. Koehler, "New method of illumination for photomicrographical purposes," *Journal of the Royal Microscopical Society*, vol. 14, pp. 261-262, 1894.



Figure 2: Working principle of Köhler illumination in epiillumination. The lighting is defocused and provides homogeneous sample illumination.

versions / no focusing is needed for telecentric optics)

- ×1 digital camera with USB connection
- Power supply and control unit for the LED light
- Main body with a flat mounting base
 - Fine screw-adjustable height positioning (Z direction)
 - Fine screw-adjustment for the X and Y positions
- Software for real-time on-screen visualisation of the • digital images³

The same elements are found in our DIM series, but in that case with two tubular microscopes instead of only one. In the DIM microscopes, two cameras are connected to a PC and provide twin images for the inspection of two distinct zones on the substrate.

A few examples of possible configurations are shown in Figure 3. To meet our client's needs, many other configurations are possible with our modular system. For example, as an alternative to our DIM system, one can use a SIM microscope mounted on a slide rail with stoppers.



³ The digital camera must be connected to a PC running Windows OS. PC and screen are not provided.

Table 1: Products specifications.

Camera		C-mount CMOS sensor, monochrome, 25 fps 2 MP resolution (1920 px \times 1080 px), 12 bits pixel depth 2.2 µm \times 2.2 µm pixel size (sensor size: 4.2 mm \times 2.4 mm)				
Coaxial illumination		Green LED (standard), adjustable intensity (with the control unit) Any other wavelength available on request				
Optics			Telecentric tube	Infinity corrected tube		
	Model		IM-TL2	IM-HQ5	IM-HQ10	
	Magnification		×2	×5	×10	
	FoV	Field of View	$2.1 \times 1.2 \text{ mm}$	$0.8 \times 0.5 \text{ mm}$	0.4 imes 0.25 mm	
	WD	Working Distance	65 mm	35.1 mm	36.9 mm	
	Resolution*		4.6 μm	2.23 μm	1.34 µm	
Mechanics			,			
	Z travel range	1.00" (25.4 mm), fine adjustment screw				
	Y travel range	1.00" (25.4 mm), fine adjustment scre operator)	" (25.4 mm), fine adjustment screw (front – back displacement, relative to the ator)			
	SIM model		SIM-TL2	SIM-HQ5	SIM-HQ10	
	X travel range	ge left – right, relative to the operator 135 mm (± 6		mm (± 67.5 mn	7.5 mm)	
	DIM model		DIM-TL2	DIM-HQ5	DIM-HQ10	
	X travel range	left – right, relative to the operator	Min. 50	mm – Up to 20	0 mm	
Dimension	S					
Tube dimensions		$H_1 \times D_1 \text{ (mm} \times \text{mm)}$	130 × Ø26	355 × ø34		
External dimensions SIM		$H \times W_1 \times W_2$ (mm \times mm \times mm)	$500\times370\times330$	533 × 370 × 330		
External dimensions DIM			$490 \times 515 \times 330 \qquad \qquad 490 \times 515 \times 330$			

*) Resolution of the complete system (digital camera + optics).

Specifications

Our product range spans three fixed magnifications: $\times 2$, $\times 5$ and $\times 10$ magnifications are available as standard. The specifications of our different products are summarized in Table 1. For quotation request, please indicate the product reference as follows:

-		TL2	
S	IM-	HQ5	
D		HQ10	

As highlighted in the example, reference **DIM-HQ10** is for the Double Image Microscope (*DIM*) with a $\times 10$ magnification optics (infinity corrected tube). If you wish to use our telecentric tubular microscope with a custommade stage, the reference IM-TL2 is for the telecentric tube alone. **Creative engineering and manufacturing** • Our engineering team is accustomed to developing products according to client's needs. In-house machining and assembling facilities shorten the time from concept to finished products.



Customized UV-LED exposure system installed on a roll-to-roll machine

Visit our website to have an insight into our other products and activities. Contact us for further technical information and to obtain a quotation.



Double image microscope



A model of wafer chuck

About Idonus

Founded in 2004, Idonus is a Swiss company that develops and manufactures special equipment for the MEMS and watchmaking industries. Our product portfolio includes UV-LED exposure systems for photolithography, IR microscope for wafer inspection, vapor phase chemical etcher for silicon-based devices. Since 2016, we also provide ion implantation services and machines for the surface treatment of materials.

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